

# IEEE TRANSACTIONS ON NANOTECHNOLOGY

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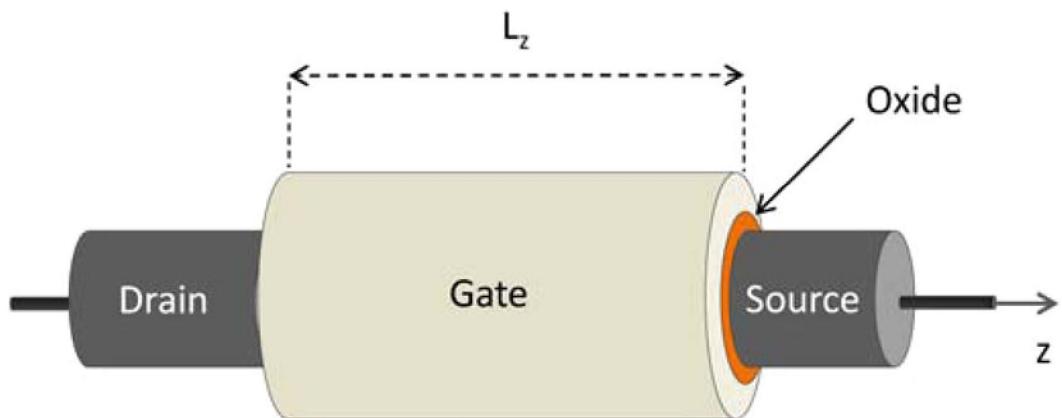
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About the cover: Schematic representation of a JL-NW-FET with the axis in the  $z$ -direction. See “An Explicit Quantum-Mechanical Compact Model for the  $I - V$  Characteristics of Cylindrical Nanowire MOSFETs,” by Ragi *et al.*, p. 628.